

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	36	(shigehiro near2 nishino or kazutoshi near2 murata). in. and (sic or silicon near2 carbide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/08 20:30
L2	28	(ring or annular \$6) near10 cvd near10 sic	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/08 20:31
L3	416	(sic or silicon near2 carbide) near15 mask \$6 near15 deposit\$6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/08 20:31
L4	9	(sic or silicon near2 carbide) near15 mask \$6 near15 deposit\$6 near16 polycrystal\$7	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/08 20:31
L5	96	(sic or silicon near2 carbide) near15 single near2 crystal \$6 near15 deposit\$6 near16 polycrystal\$7	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/08 20:32
L6	24	(sic or silicon near2 carbide) near15 (graphite near5 mask\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/08 20:32

L7	45	(cvd or vapor near2 deposit \$6) near10 (sic or silicon near2 carbide) near10 side near5 (substrate or wafer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/06/08 20:32
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